

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | DAVID J. BAIN, ET AL. |) |
| | |) Group Art Unit: 2836 |
| Serial No.: | 10/710,653 |) |
| | |) |
| Filed: | July 27, 2004 |) Examiner: Roman, L. |
| | |) |
| For: | PRESSURE ASSISTED WAFER |) |
| | HOLDING APPARATUS AND |) Confirmation No.: 4652 |
| | CONTROL METHOD |) |

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office Action mailed January 11, 2008, please amend the
Application as follows: